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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP05/13413 07/21/2005

** FOREIGN APPLICATIONS *****

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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	66	32	4

ADDRESS

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TITLE

Bistable resistance value acquisition device, manufacturing method thereof, metal oxide thin film, and manufacturing method thereof

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)